Electronic Supplementary Information (ESI)

A Scalable Fabrication Method for Gold Nanodisk-Upconverting Nanoparticle Hybrid Nanostructures

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Figure S1. (A) TEM image of as-synthesized NaYF₄: Yb³⁺, Tm³⁺ UCNPs. Scale bar is 100 nm. (B) Distribution of the NaYF₄: Yb³⁺, Tm³⁺ UCNPs diameters as calculated from the TEM images using ImageJ.



Figure S2. Large scale SEM images of self-assembled UCNP films prepared with a UCNP concentrations of 0.01 mg/mL and ethanol amount of (A) 800 μ L and (B) 200 μ L. Scale bar is 500 nm.



Figure S3. (A-D) Representative AFM maps of the plasmonic nanoarray on PDMS-UCNP layers after the PDMS in between the structures was etched away, exposing the UCNPs in the background. (E) Distributions of the hybrid nanostructure heights as obtained from $3 \times 3 \mu m^2$ AFM maps for the different PDMS concentrations.



Figure S4. SEM images of PR hole and gold nanodisk arrays fabricated with exposure doses of (A,D) 6.6 mJ/cm², (B,E) 7.4 mJ/cm², and (C,F) 9.9 mJ/cm². Scale bar is 500 nm. (G) Correlation between PR hole and gold nanodisk diameters as a function of exposure dose and with a period of 440nm. Inset shows a sideview of the PR holes (at 9.9 mJ/cm²) after gold evaporation. The presence of undulation on the sidewall prevents the formation of a continuous gold film which helps with the lift-off process. The thickness of the deposited gold nanodisks is around 30 nm as expected. Scale bar is 200 nm.



Figure S5. SEM images of gold disks fabricated at an exposure dose of 8.5 mJ/cm2, 250 nm period, and pre-baking for 1 minute at (A) 150 °C, (B -C) 125 °C. Scale bar is 1 µm.



Figure S6. (A) PDMS etching depth as a function of RIE time. (B-C) Representative AFM maps of the periodic PDMS grating created after RIE and PR removal.